



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 19, 2026	
IGI Report Number	LG775626660
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.23 X 5.84 X 3.58 MM

GRADING RESULTS

Carat Weight	1.09 CARAT
Color Grade	D
Clarity Grade	VS 1

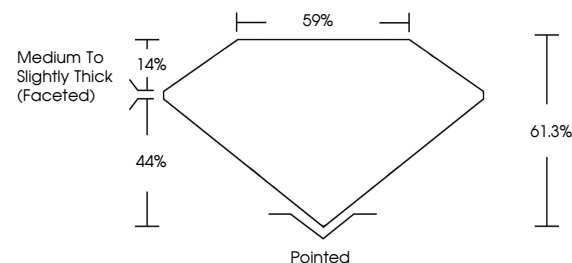
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG775626660

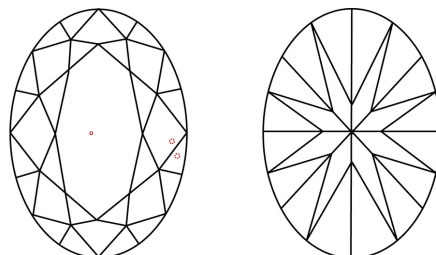
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG775626660
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

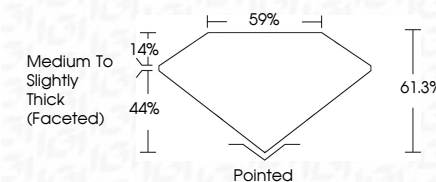
LABORATORY GROWN DIAMOND REPORT



February 19, 2026	
IGI Report Number	LG775626660
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.23 X 5.84 X 3.58 MM

GRADING RESULTS

Carat Weight	1.09 CARAT
Color Grade	D
Clarity Grade	VS 1



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG LG775626660
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES

www.igi.org

January 19, 2025	1,09 CARAT
GIA Report No. LG775626660	D
VERY BRILLIANT	VS 1
	61.5%
	59%
	Medium to Slightly Thick (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	681 LG775626660

Comments: This is a Very Good Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA